



PATENT  
Docket No.: MAN-013

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2131

Examiner: Zia, Syed

Serial No.: 10/723,285

Filed: November 25, 2003

In re Application of: Werner et al.

For: SEMICONDUCTOR STRUCTURE FOR USE IN THE NEAR INFRARED  
REGION AND A METHOD OF MANUFACTURING THIS SEMICONDUCTOR  
STRUCTURE

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 1/3/06.

Signed Krista Thompson  
Krista Thompson

**PRELIMINARY AMENDMENT AND**  
**REQUEST FOR CONTINUED EXAMINATION**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to Office Action dated July 5, 2005 and the Advisory Action dated December 2, 2005, kindly amend the above-identified application as follows: